

Electronic Patent Application Fee Transmittal

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|--|--|-----------------|---------------|-----------------------------|
| Application Number: | 10674568 | | | |
| Filing Date: | 29-Sep-2003 | | | |
| Title of Invention: | Method and system for monitoring an etch process | | | |
| First Named Inventor/Applicant Name: | Matthew Fenton Davis | | | |
| Filer: | Keith Patrick Taboada | | | |
| Attorney Docket Number: | 6716/ETCH/SILICON | | | |
| Filed as Large Entity | | | | |
| Utility under 35 USC 111(a) Filing Fees | | | | |
| Description | Fee Code | Quantity | Amount | Sub-Total in USD(\$) |
| Basic Filing: | | | | |
| Pages: | | | | |
| Claims: | | | | |
| Miscellaneous-Filing: | | | | |
| Petition: | | | | |
| Patent-Appeals-and-Interference: | | | | |
| Filing a brief in support of an appeal | 1402 | 1 | 540 | 540 |
| Post-Allowance-and-Post-Issuance: | | | | |
| Extension-of-Time: | | | | |

| Description | Fee Code | Quantity | Amount | Sub-Total in USD(\$) |
|-----------------------------------|----------|----------|--------|----------------------|
| Extension - 1 month with \$0 paid | 1251 | 1 | 130 | 130 |
| Miscellaneous: | | | | |
| Total in USD (\$) | | | | 670 |